

Res'd PCT/PTO 16 MAY 2005

JFQ

DOCKET NO: 270968US2X PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
SHINSUKE HARADA, ET AL. : ATTN: APPLICATION DIVISION  
SERIAL NO: 10/531,582 :  
FILED: APRIL 18, 2005 :  
FOR: SILICON CARBIDE :  
SEMICONDUCTOR DEVICE AND :  
ITS MANUFACTURING METHOD :

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to a first examination on the merits, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 6 of this paper.

**Amendments to the Drawings** begin on page 15 of this paper and include an attached replacement sheet.

**Remarks** begin on page 16 of this paper.